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Itaru HOMMA et al.Filing Date  
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Unassigned**U.S. PATENT DOCUMENTS**

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**FOREIGN PATENT DOCUMENTS**

Document Number	Date	Country	Class	Sub Class	YES	Translation NO
2002-217071	August 2, 2002	Japan				
2000-012404	January 14, 2000	Japan				

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

	R. MOENE et al., Coating of activated carbon with silicon carbide by chemical vapour deposition, CARBON, 1996, Vol. 34, No. 5, pages 567 to 579
	TACHUNG WANG et al., 25 Modelign of copper (II) removal by iron oxide-coated granular activated carbon, Proc. Ind. Waste. Conf., 1996, Vol. 50th, pages 227 to 235

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